

Title (en)

Sialon insert and cutting tool equipped therewith

Title (de)

Sialon-Einsatz und damit ausgestattetes Schneidewerkzeug

Title (fr)

Insert en sialon et outil de découpe doté de celui-ci

Publication

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Application

**EP 11180944 A 20051222**

Priority

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Abstract (en)

[origin: EP1837105A1] This invention provides a long-life Sialon insert, the cutting edge of which is resistant to wear and hard to fracture, and a cutting tool equipped with the Sialon insert. Provided are a Sialon insert made of a Sialon sintered body including a Sialon phase comprising an  $\pm$ -Sialon and a  $^2$ -Sialon, and at least one element, originating from a sintering aid, selected from the group consisting of Sc, Y, Dy, Yb, and Lu in an amount of 0.5 to 5 mol% in terms of an oxide thereof, wherein an  $\pm$ -value, which shows the proportion of the  $\pm$ -Sialon in the Sialon phase, is from 10% to 40%; the  $^2$ -Sialon has a value of Z from 0.2 to 0.7 wherein Z is a variable of the formula Si 6-Z Al Z O Z N 8-Z and within a range: 0<Z<4.2; and the sintered body has an average thermal expansion coefficient of  $3.5 \times 10^{-6}$  /K or less at temperatures of room temperature to 1000°C, and a thermal conductivity of 10 W/m#K or more at temperatures of room temperature to 1000°C, and a cutting tool comprising a holder equipped with the Sialon insert.

IPC 8 full level

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DE FR SE

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